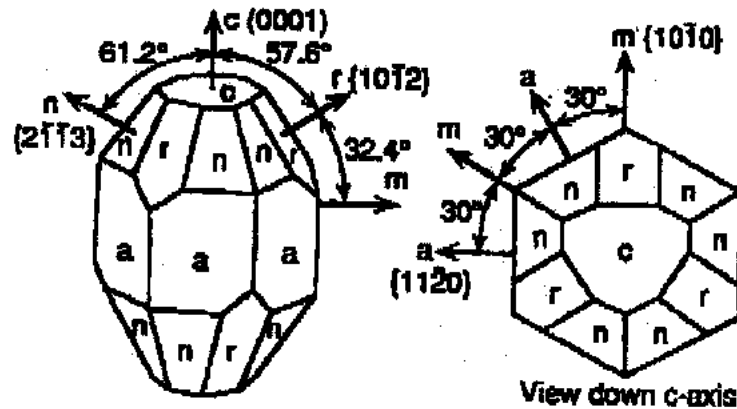

Core Optics

Sapphire Development

GariLynn Billingsley
Caltech seminar
4 March 2003

Introduction to Sapphire

- Advanced LIGO baseline Test Mass – Sapphire
 - » Greater Astronomical reach
 - Thermal characteristics
 - Mechanical properties
 - » Large, optical quality sapphire is not yet an “off the shelf” item



● Figure 1. Sapphire (α -Al₂O₃) crystal showing mineralogical and Miller index notation.

Material Production

- Five experimental growth runs Crystal Systems
 - » Two of five 15” boules are considered good optical quality
 - » Two of five are not
 - » LIGO has bought one “good” and one “not” to test for use as transmissive and non-transmissive test masses
 - Plan to measure absorption, scatter, homogeneity, Q
 - » CSI is moving on to concentrate on 20” boules
- Shanghai Institute of Optics and Fine Mechanics
 - » Furnace is in place
 - » No large pieces yet
- Rubicon
 - » Just received 150 mm piece for optical testing, and 10 cubes for absorption tests

Polishing Surface One

- CSIRO and Wave Precision have good results
 - » Microroughness to $\sim 1\text{\AA}$
 - » CSIRO better figure (better metrology)

More at <http://www.ligo.caltech.edu/~gari/sysmtg.html>

LADI CERTIFICATION DATA

Title: Sapphire A side 1

CSIRO

Date: 04/06/01

Astig: 1.8 nm

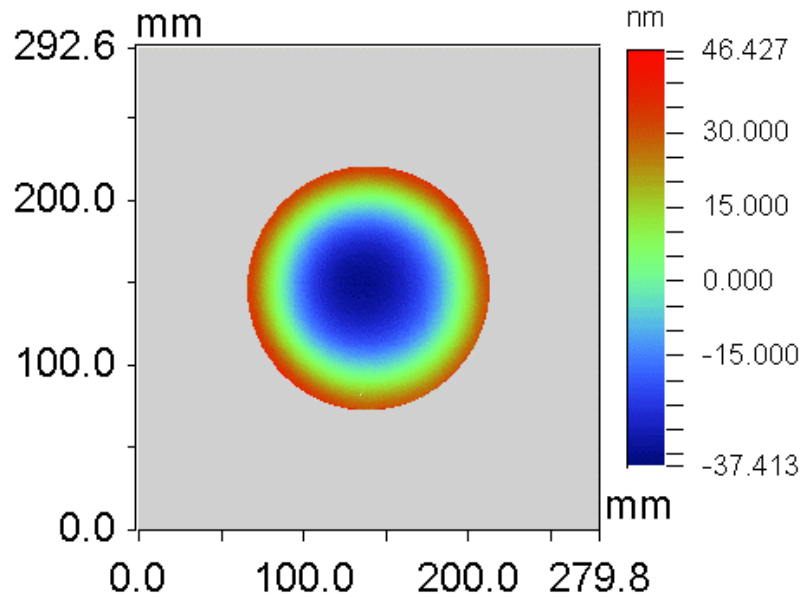
PV: 5.9 nm

Diameter: 120 mm

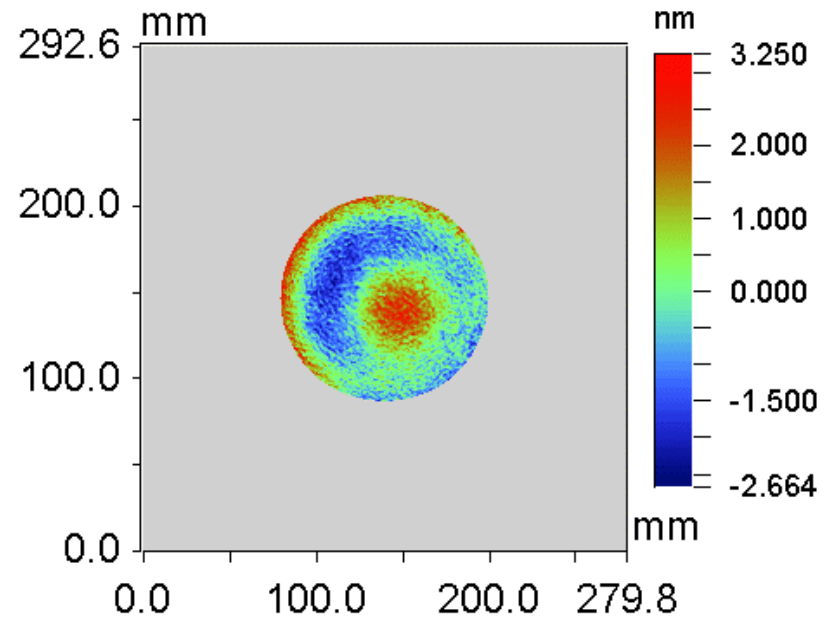
Power: 47.1 nm

RMS: 1.0 nm

Tilt Removed

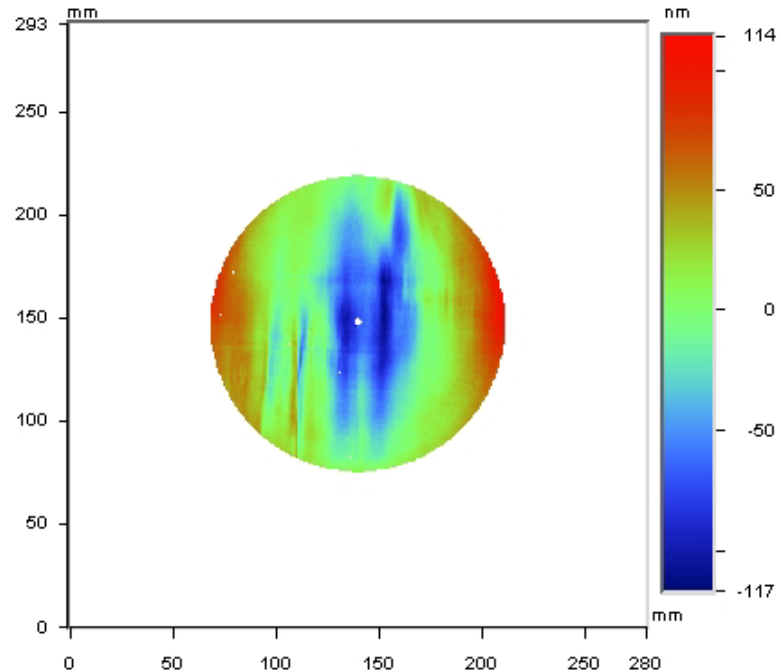


Tilt/Power/Astig Removed



Homogeneity

- Can't get c-axis in sizes
314 mm x 130 mm
- The problem with m- and a-axis sapphire...

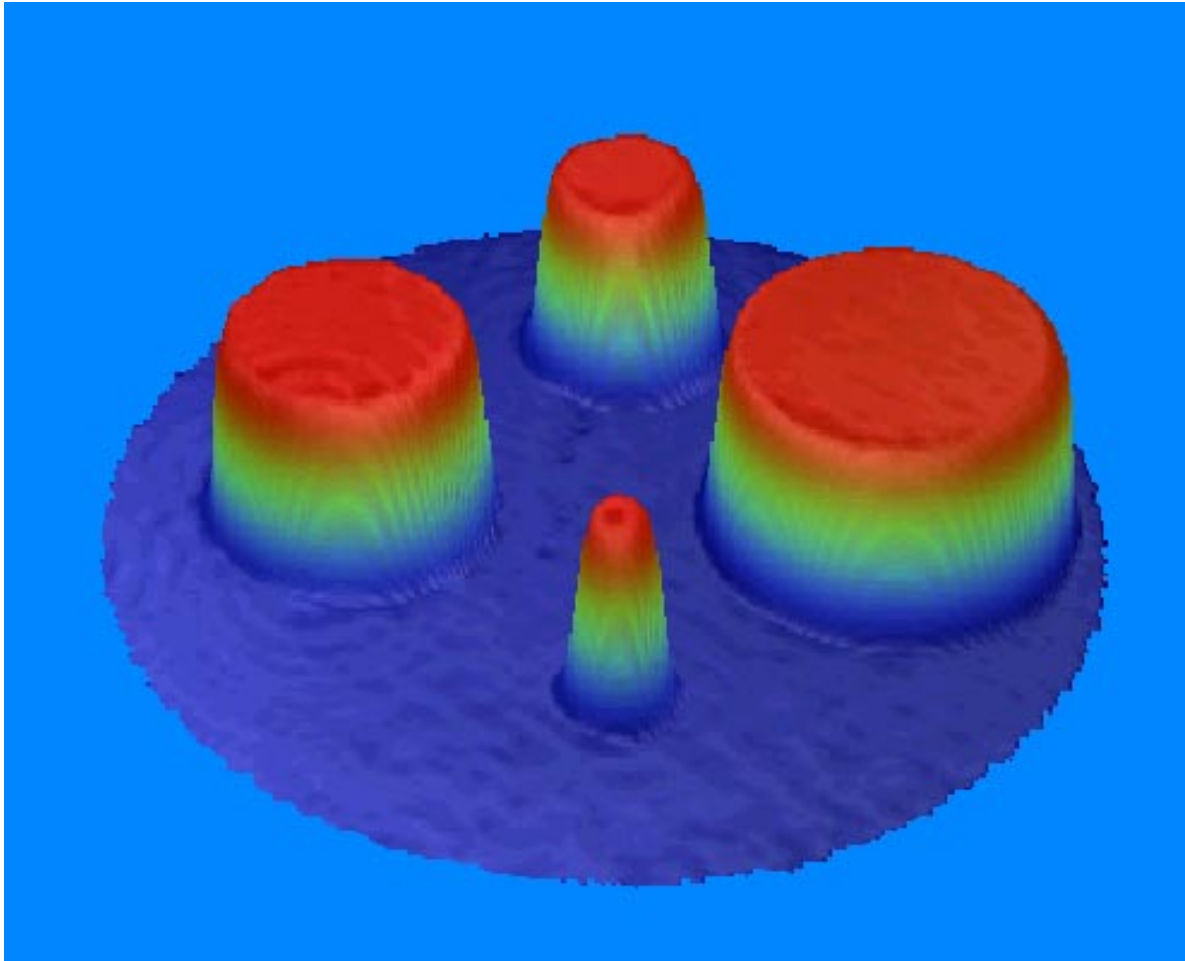


Date: 08/11/2000	X Center: 280.00
Time: 14:23:44	Y Center: 280.00
Wavelength: 690.700 nm	Radius: 143.43 pix
Pupil: 100.0 %	Terms: Tilt
PV: 231.4251 nm	Filters: None
RMS: 41.4312 nm	Masks:

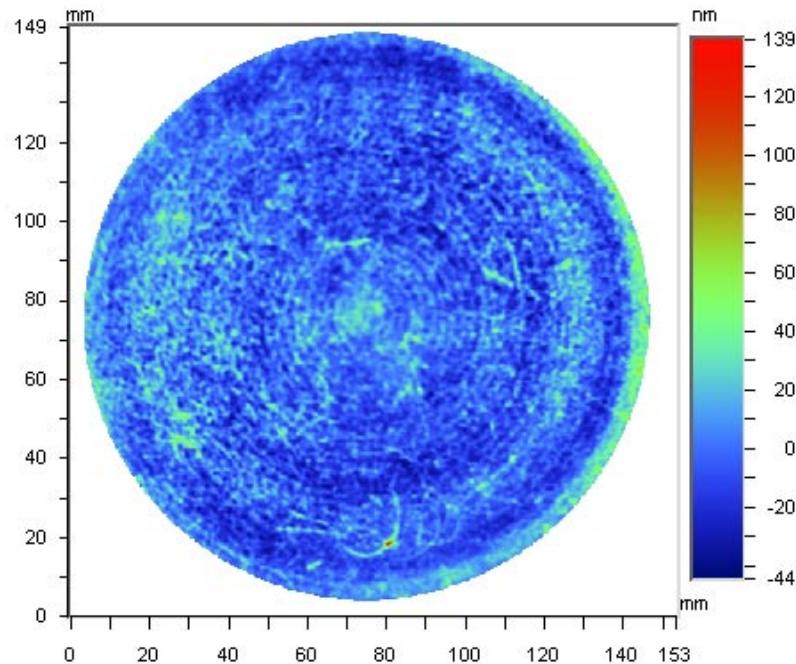
Homogeneity Compensation

- Compensation studies
 - » CSIRO
 - Fluid jet polishing
 - Compensating coating deposition
 - Ion beam etch
 - » Goodrich (formerly Perkin Elmer, HDOS, Raytheon)
 - Computer controlled polishing

Ion beam etch wins most sexy approach



Compensating Polish by Goodrich wins most mature approach



Date: 04/16/2002

Time: 14:37:03

Wavelength: 1.064 μm

Pupil: 100.0 %

PV: 183.6397 nm

RMS: 14.6141 nm

X Center: 282.00

Y Center: 243.00

Radius: 269.89 pix

Terms: Tilt

Filters: None

Masks: Detector Mask

Absorption

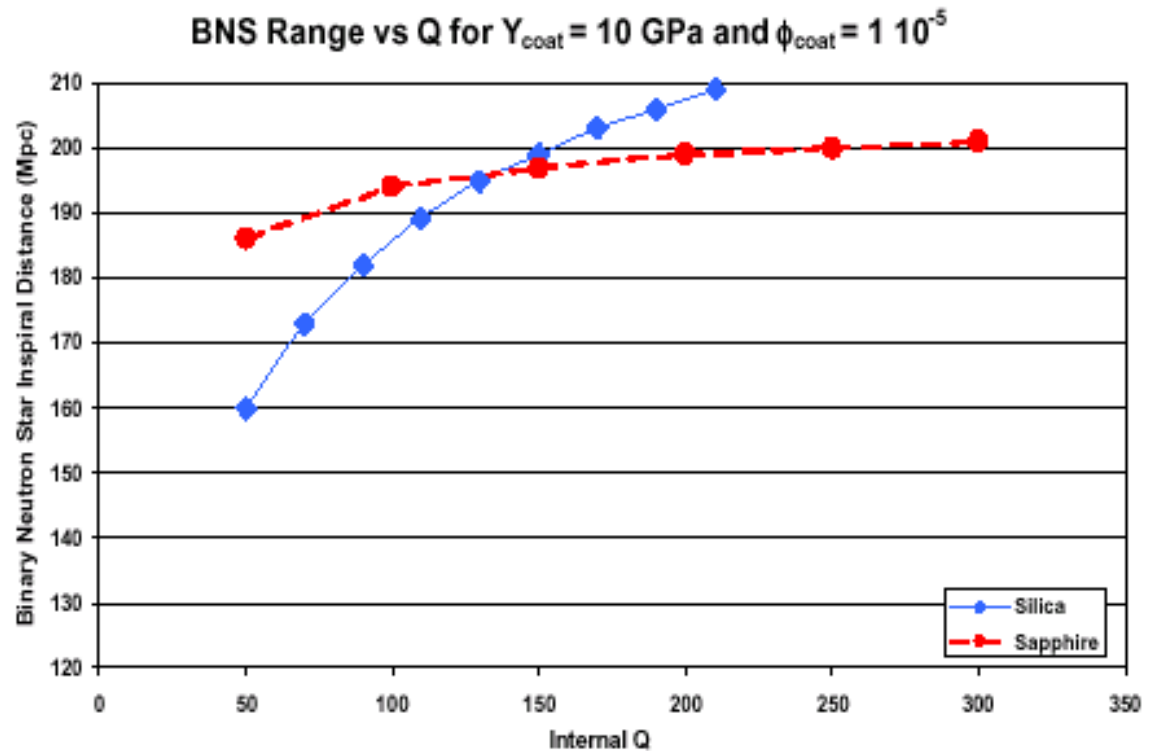
- Absorption is studied at Stanford – Route, Fejer
 - » 10 ppm/cm required in order to throw out active thermal compensation
 - » Typically 50 ppm/cm in large samples as received
 - » Isolated observations at 10 ppm/cm, existence proof
 - » Annealing Studies have produced 20 – 30 ppm/cm to date
- Response – Active thermal compensation
 - » Ryan Lawrence Thesis at MIT
 - » Dave Ottaway taking over for Ryan Lawrence at MIT
 - » Full cavity experiment at Gin Gin, Western Australia
- Measure profile in full size boule at Lyon 3-03
 - » Ring heater or scanned laser approach depends on these results

Sapphire Q

- Phil Willems has begun measurement of full size pieces
 - » 314 mm x 130 mm boules measured $Q \sim 2 \times 10^8$
 - For a mode with no motion at the barrel

Fused silica-not out of the running

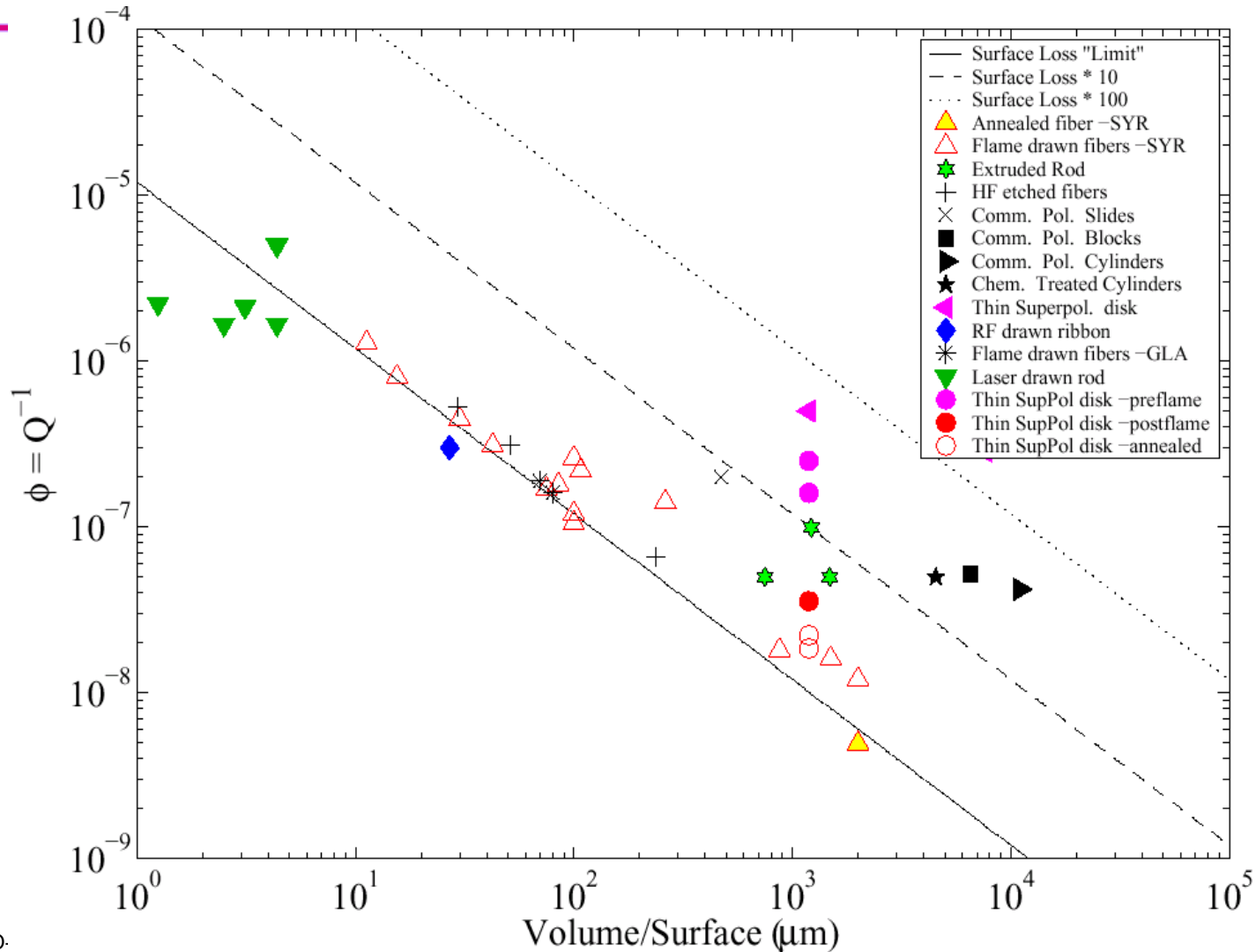
- Higher Q in FS – performance ~ as good as that of sapphire
 - » Best choice depends on coating
 - » Highest modal Q of a fused silica sample observed to date is approximately 200 million, observed at Syracuse
 - » Annealing studies needed



Modeled using Bench – G. Harry T030007

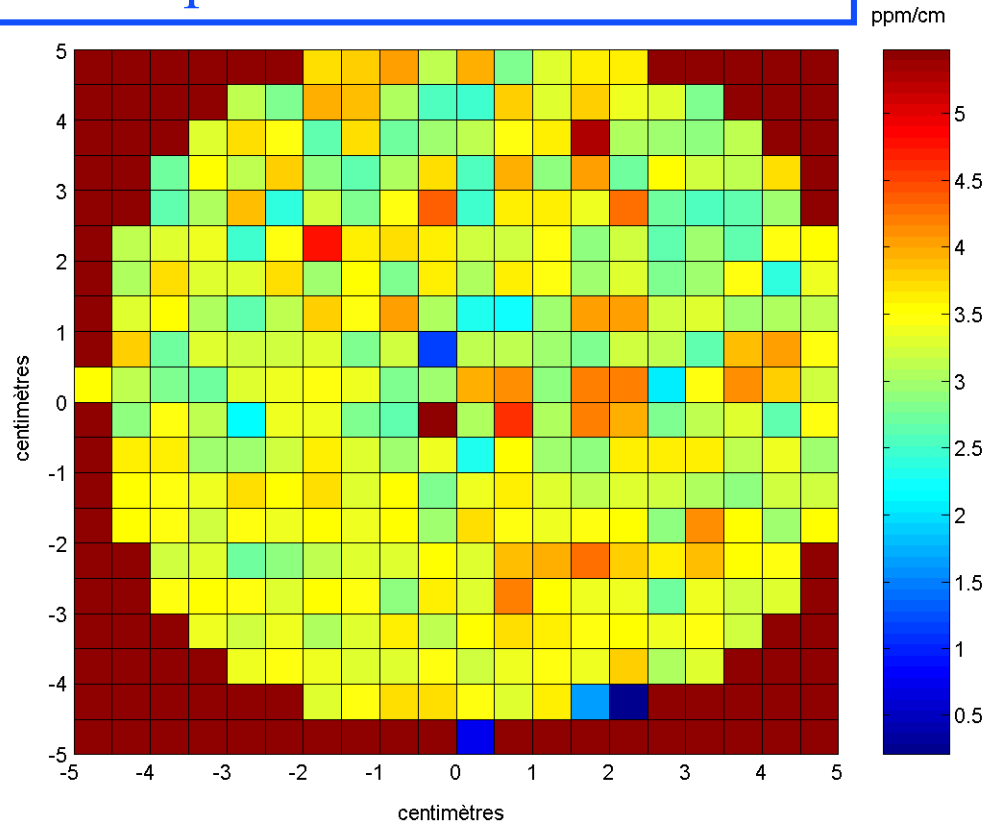
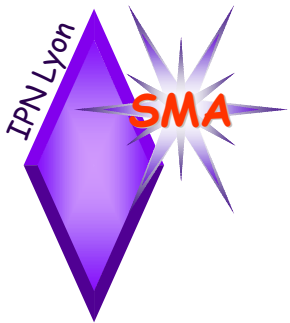
-Steve Penn-

Surface loss limited Q for full size FS $\sim 4 \times 10^9$
 presume the bulk loss will dominate at some point



Measurements on fused silica

Bulk absorption map. Φ 300 mm Heraeus Substrate



Challenges

- Scatter, Absorption in large sapphire is unknown
 - » Testing February-June
 - » Rigorous calculation of acceptable Recycling Cavity loss
- New FS Q data opens up a new line of inquiry
 - » Annealing studies
 - » Surface studies
- High thermoelastic noise in sapphire is reduced with a large beam footprint (D'Ambrosio et al)
 - » Providing good polish is obtainable to edge of large optics
 - » Investigate control of such a cavity – benchtop?

Schedule Milestones

- Delivery of first two large sapphire substrates Feb '03
- Measurement of first two large sapphire substrates
 - » Q, Phil Willems, CIT – In process
 - » Absorption map, SMA Lyon
 - » Scatter map, SMA Lyon or CIT (instrument being built at CIT)
 - » Homogeneity, CIT
- Material down-select – July '03
- Install LASTI test masses – October '04